



Patent  
Attorney Docket No. 015290-500

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Si Yi Li et al.

Application No.: 09/820,695

Filing Date: March 30, 2001

Title: METHOD OF PLASMA ETCHING LOW-K DIELECTRIC MATERIALS

Group Art Unit: 1763

Examiner: A. W. Olsen

Confirmation No.: 4162

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following extension of time is requested to: respond to the Office Action mailed February 27, 2004.

one month to June 27, 2004 ☐ \$55.00 (2251) ☒ \$110.00 (1251)

☐ The shortened statutory period has been reset by an Advisory Action dated \_\_\_\_\_.

☐ An extension fee in the amount of \_\_\_\_\_ is enclosed.

☒ Charge \$ 110.00 to Deposit Account No. 02-4800.

☐ Charge \_\_\_\_\_ to credit card. Form PTO-2038 is attached.

The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

P.O. Box 1404  
Alexandria, Virginia 22313-1404  
(703) 836-6620

By

Edward A. Brown

Registration No. 35,033

Date: June 28, 2004

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